

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/695,336

Applicant(s): Geiss et al.

Filed.: October 28, 2003

Art Unit: 2813

Dkt. No.: BUR920010184US2

Examiner: DOTY, HEATHER ANNE

Title: **METHOD OF CONTROLLING GRAIN SIZE IN A POLYSILICON LAYER AND
IN SEMICONDUCTOR DEVICES HAVING POLYSILICON STRUCTURES**

Honorable Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

This Request for Reconsideration is being filed in response to the Final Office Action mailed on January 29, 2007. Applicants request this Amendment be entered in the above-identified application and reconsideration of the application in view of the Amendments and Remarks that follow.